Polarity effects in the x-ray photoemission of ZnO and other wurtzite semiconductors

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ZnO is a candidate for next-generation optoelectronic devices due to a unique combination of properties, including a wide direct band gap in the ultraviolet-A spectrum, efficient above room temperature free-excitonic emission, and large spontaneous and piezoelectric polarizations. However, many of the optical and electrical properties of ZnO, including photoluminescence, cathodoluminescence, near-surface electron accumulation, and the barrier heights of Schottky contacts vary with crystallographic polarity. Polarity also plays an important role in ZnO growth, affecting surface morphology, crystal quality, and dopant incorporation. Existing methods for determining the polarity of ZnO surfaces, which include wet etching, coaxial impact-collision ion scattering spectroscopy, and x-ray diffraction, are time consuming and difficult to perform in situ during film growth and device fabrication.

X-ray photoemission spectroscopy (XPS) is a widely used tool for probing the chemical and electronic nature of semiconductor surfaces, with in situ XPS increasingly used during the growth of epitaxial films and heterostructures. In this letter, we report significant polarity-related differences in the XPS spectra of ZnO and other wurtzite semiconductors which provide a simple nondestructive indicator of crystallographic polarity.

ZnO crystallizes into the wurtzite structure which when viewed along the c-axis (Fig. 1) consists of alternating planes of Zn and O atoms, arranged in threefold coordinated “double layers” separated by a single Zn–O bond. Truncation of the crystal along this axis always results in one of two polar surfaces—the Zn-polar [ZnO(0001)Zn] face or the O-polar [ZnO(0001)O] face. Due to the large electronegativity of oxygen, these polar faces have a significant ionic character and are electrostatically unstable. Three stabilization mechanisms are commonly proposed: (a) a fractional negative charge transfer from the O-polar to Zn-polar face, (b) a surface reconstruction which removes 25% of the surface atoms, and (c) the adsorption of hydroxide [hydrogen] on the Zn-polar [O-polar] face. In the case of the Zn-polar face, some form of condition-dependent (i.e., pH, temperature, H2/H2O partial pressure) competition between the formation of triangular islands and pits with O-terminated step edges and the adsorption of hydroxyl (OH) groups may occur. The O-polar face, except under rare circumstances, has been shown to exhibit an unreconstructed (1 × 1) H-termination.

Polarity-related differences in the XPS spectra of ZnO were investigated using c-axis, m-plane (1100), and a-plane (1120) bulk ZnO single crystal wafers (10 × 10 × 0.5 mm3) grown using both the hydrothermal (HT) and pressurized-melt (PM) techniques. The carrier concentration of the HT and PM ZnO material was 10¹³–10¹⁴ cm⁻³ and 10¹⁶–10¹⁷ cm⁻³, respectively, allowing the influence of bulk conductivity to also be investigated. Zn-polar and O-polar face samples were cut from the same double-sided polished c-axis wafers. All samples were ultrasonically cleaned using...
TABLE I. XPS (hν=1486.6 eV) quantification analysis of the organic-solvent cleaned Zn-polar, O-polar, and m-plane faces of HT ZnO before and after 20 min ROP exposure.

<table>
<thead>
<tr>
<th>Preparation</th>
<th>Sample</th>
<th>Zn</th>
<th>O</th>
<th>C</th>
<th>Zn/O</th>
</tr>
</thead>
<tbody>
<tr>
<td>Organic solvent cleaned</td>
<td>Zn-polar</td>
<td>34.0</td>
<td>51.4</td>
<td>14.6</td>
<td>0.66</td>
</tr>
<tr>
<td></td>
<td>O-polar</td>
<td>35.7</td>
<td>47.1</td>
<td>17.2</td>
<td>0.75</td>
</tr>
<tr>
<td></td>
<td>m-plane</td>
<td>35.8</td>
<td>45.0</td>
<td>19.3</td>
<td>0.79</td>
</tr>
<tr>
<td>Remote oxygen plasma cleaned</td>
<td>Zn-polar</td>
<td>45.2</td>
<td>52.4</td>
<td>2.4</td>
<td>0.86</td>
</tr>
<tr>
<td></td>
<td>O-polar</td>
<td>49.3</td>
<td>47.9</td>
<td>2.8</td>
<td>1.03</td>
</tr>
<tr>
<td></td>
<td>m-plane</td>
<td>49.9</td>
<td>47.5</td>
<td>2.6</td>
<td>1.05</td>
</tr>
</tbody>
</table>

organic solvents (acetone, methanol, and isopropyl alcohol) and dried in N₂ gas. XPS measurements were performed using a Kratos Ultra DLD spectrometer and monochromated Al Kα radiation (hν=1486.6 eV) at Purdue University and at the soft x-ray beamline of the Australian Synchrotron using photon energies from 150 to 1486 eV. Unless otherwise stated, the spectra were collected with the detector axis normal to the sample surface (take-off angle θ=90°). Monochromated Al Kα XPS measurements were also carried out on additional samples using a Kratos XSAM800 spectrometer at the University of Auckland and a Scienta ESCA 300 spectrometer at the National Centre for Electron Spectroscopy and Surface Analysis, Daresbury Laboratory U.K., to confirm the reproducibility of the polarity-related effects. All samples were carefully grounded to the respective spectrometer (including samples with indium back contacts) to avoid peak distortion due to sample charging.

We first consider polarity-related differences in the core-level XPS spectra of ZnO: Al Kα XPS survey spectra were taken from the Zn-polar, O-polar, and m-plane faces of organic-solvent cleaned HT ZnO. In each case, the survey spectra identified Zn, O, and C as the only elements present in the near-surface region. The atomic concentrations of each element were determined from the areas of the Zn 2p, O 1s, and C 1s core-level peaks using sensitivity factors based on spectrometer-modified Scofield cross-sections. Table I shows the results of this quantification analysis before and after 20 min of remote oxygen plasma (ROP) exposure. Surprisingly, the Zn/O ratio determined for the Zn-polar face was significantly lower. On further investigation, this effect was found to be a consistent phenomenon across multiple HT and PM ZnO wafers.

The origin of the lower Zn/O ratio on the Zn-polar face may be due to a different surface reconstruction and/or the presence of different terminating species compared to the other faces: atomic force microscopy images of the Zn-polar face of HT ZnO revealed the presence of a high density of triangular shaped terraces and pits, similar to those observed by Dulub et al.,10 which are not present on the O-polar or m-plane faces. Since the step edges of these features are O-terminated, they lower the effective Zn/O ratio on the Zn-polar face.10,12

The termination of the ZnO surface can be determined from the O 1s core-level spectra. Figure 2 shows O 1s spectra taken at different photon energies (1486 to 600 eV) from organic-solvent cleaned HT ZnO samples at the Australian Synchrotron. The surface sensitivity of the spectra increases with decreasing photon energy, since the inelastic mean free path of the photoemitted electrons is a function of their kinetic energy and approaches a minimum at ~70 eV. For hν=1486 eV, the dominant emission is at 530.8 eV due to oxygen in the bulk, with a high binding energy shoulder at 532.3 eV associated with the presence of OH groups.12,14

The intensity of the OH contribution increases significantly with decreasing photon energy indicating that all three faces contain a significant amount of OH bonding localized at the surface. Since the hydroxyl termination at the Zn-polar face is ZnO(OOH) compared to ZnO(OOH)–H for the O-polar face,12,14 hydroxylation of the ZnO surface effectively places additional O atoms at the Zn-polar face, also lowering the Zn/O ratio.

We now consider polarity-related differences in the valence band XPS (VB-XPS) spectra of ZnO: The position of the low binding energy edge of the VB-XPS spectra has previously been used to investigate the near-surface band bending in ZnO.4 Here, we focus on the shape of the VB-XPS spectra which is closely related to the total valence band density of states.17 Figure 3(a) shows VB-XPS spectra collected from the Zn-polar, O-polar, and m-plane faces of HT ZnO using Al Kα radiation. The VB-XPS spectra consist of two main peaks—peak I at ~5.0 eV which has been attributed to predominately O 2p derived states and peak II at ~7 eV which has a hybridized O 2p, Zn 4s, and (possibly) Zn 3d character.17,18 While the intensity of peak II is similar on all three faces, a striking polarity-related effect involving the intensity of peak I is evident. Peak I is significantly more intense than peak II on the Zn-polar face, while on the O-polar face it is slightly weaker. The intensity of peak I on the nonpolar m-plane face is intermediate between that on the two polar faces. The same effect was consistently observed on the Zn-polar, O-polar, and a-plane faces of PM ZnO [Fig. 3(c)] and on multiple additional wafers of both types. Interestingly, Ohashi et al.19 also observed a structure, at a similar binding energy to peak I, in the hard (hν =5946.8 eV) x-ray VB-XPS spectra of ZnO for only the Zn-polar face.
Since peak I has been attributed to mainly O 2p derived VB states,\textsuperscript{17,18} the increased intensity of this peak on the Zn-polar face could be a surface effect linked to the lower Zn/O ratio and/or the nonhybridized O-orbitals in the OH termination of this face. However, the polarity effect disappears in spectra measured at a take-off angle of $\theta=30^\circ$ to the sample surface [Figs. 3(b) and 3(d)] which represents a two-fold increase in surface sensitivity. This indicates that the polarity effect has a strong directional dependence and may be linked to the lack of inversion symmetry of the wurtzite structure rather than differences in surface reconstruction and chemistry.

The VB-XPS polarity effect was also investigated using synchrotron radiation as shown in Figs. 3(e) and 3(f). The same striking polarity-related difference in the intensity of peak I was observed at photon energies from 1486 to 600 eV, however, at photon energies below 600 eV the difference disappeared. Since the photoemission cross-sections for O 2p and Zn 4s states are similar in nature over the photon energy range investigated,\textsuperscript{20} this also suggests a structural-related cause for the polarity effect. VB-XPS spectra were also taken from the polar faces of double-sided polished c-axis CdS and CdSe single crystals. Figures 4(a) and 4(b) show a similar polarity effect for these II–VI wurtzite semiconductors. In addition, Veal et al.\textsuperscript{21} reported a similar effect in the VB-XPS spectra of InN, which we have also observed in GaN (not shown). This links the polarity effect to the common wurtzite structure rather than to specific differences in the surface chemistry of these semiconductors.

In summary, the polar and nonpolar surfaces of ZnO were investigated using XPS. Two significant polarity-related effects were observed in that the Zn/O ratio was consistently lower on the Zn-polar face than on the O-polar and m-plane faces, while photoemission (for $hv=1486$ to 600 eV) from the lowest binding energy valence band states was significantly stronger on the Zn-polar face. The latter provides a reliable nondestructive indicator of surface polarity in ZnO which can be used in situ during growth and device fabrication.

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